

Notice of References Cited	Application/Control No.		Applicant(s)/Patent Under Reexamination	
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	Examiner		Art Unit	Page 1 of 1
Eric B. Chen		1765		

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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	U	Kern, Handbook of Semiconductor Wafer Cleaning Technology, 1993, Noyes Publications, pp. 123, 125-126.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.